SUB-SYSTEMS FOR OPTICAL FREQUENCY MEASUREMENTS: APPLICATION TO THE 282 NM $^{199}\text{Hg}^+$ TRANSITION AND THE 657 NM CA LINE.

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ABSTRACT

We are developing laser frequency measurement technologies that should allow us to construct an optical frequency synthesis system capable of measuring optical frequencies with a precision limited by the atomic frequency standards. The system will be used to interconnect and compare new advanced optical-frequency references (such as Ca, Hg^+ and others) and eventually to connect these references to the Cs primary frequency standard. The approach we are taking is to subdivide optical frequency intervals into smaller and smaller pieces until we are able to use standard electronic-frequency-measurement technology to measure the smallest interval.

1. DOMAIN-ENGINEERED LITHIUM-NIOBATE FOR OPTICAL SYNTHESIS

Ideally the optical-frequency-measurement system would be constructed from self-similar frequency dividing units that use compact lasers, simple nonlinear optical-mixing elements that are easy to assemble, and then run reliably. With this goal in mind we have constructed and evaluated the performance of a number of diode-laser systems and optical-mixing stages. We have made progress in fabricating and using periodically poled lithium-niobate (PPLN) nonlinear crystals for most of the mixing stages in our optical synthesis system. With extended-cavity diode lasers (ECDLs) and a CO $\Delta v=2$ laser we have tested these crystals for practicality and efficiency in second-harmonic generation (SHG), sum-frequency generation (SFG), difference-frequency generation (DFG), and even third-harmonic generation (THG) [1]. By designing and fabricating the crystals for specific interactions we can achieve efficient nonlinear mixing (see Fig. 1).

Optical-grade lithium niobate (transparency window from 330-5500 nm) is readily available, and periodically poled crystals are now being produced commercially with various poling periods. Since not all of the poling periods that we needed were available, we developed our own poling capability at NIST. The poling is done by the electric-field method, and we have now poled a number of samples with poling-periods ranging from 8 to 36 μm .

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Figure 1. Second harmonic power versus crystal temperature using 5mW of 1315 nm diode laser radiation to produce 200 nW of 657 nm light in a single pass through a 20 mm long PPLN crystal. This is adequate power to phase-lock the 1315 nm laser to the 657 nm reference laser.

Domain-engineered materials (of which PPLN is by far the most common) are a powerful and practical tool for the general task of optical-frequency synthesis [2]. We have used PPLN for a wide range of nonlinear mixing applications, some of which are summarized in Table 1. For example we have explored all possible combinations of mixing between three important wavelengths (563 nm, 657 nm and 3925 nm) used in our present synthesis scheme. By pure luck, these mixings require the same poling period (12.6 μm) that we need for SHG of 1314 nm to reach 657 nm. Further evidence for the usefulness of this material as an optical mixer were weak blue and green beams that we observed coming out of a crystal designed for first order DFG using 800 nm minus 1064 nm to produce 3.4 μm . These short-wavelength beams were the two SHG signals and the SFG signal that were phase-matched at slightly different angles and high orders of the poling period [1]. In a special case, it was even possible to achieve third harmonic generation of a cw laser at 3561 nm as a result of cascaded second order nonlinearities, that simultaneously phase-matched second-harmonic generation and sum frequency mixing.

Table 1. Characteristics of the different PPLN stages involved in the studies

PPLN stage	SHG#1	SHG#2	DFG#1	DFG#2	SHG Test	DFG Test	DFG Test	DFG Test	DFG Test
Period (μm)	29.9	12.7	12.6	30.9	32.7	12.6	22.2	30.75	31.0
Temp ($^{\circ}\text{C}$)	87	24	31	34	87	31	61	83	42
λ in (nm)	3925	1308	563 3925	1308 3925	3378	657 563	810 1064	1064 2902	1064 2860
Power in (mW)	100	5	15 50	4 80	200	4 20	50 250	300 65	300 48
λ out (μm)	1962	654	657	1962	1689	3925	3393	1680	1694
Power out (nW)	2500	200	4000	150	10000	10	4000	2500	2500

Domain-engineered materials such as PPLN might begin to play the role of a universal optical mixer. Unfortunately, optical nonlinearities are tiny in comparison to what can be achieved at lower frequencies, with microwave harmonic-mixer diodes, for example. Using low-power cw lasers we are basically limited to second order optical nonlinearities which do not create high-order mixing products efficiently. In addition, some technical challenges still limit the usefulness of PPLN in the short-wavelength regions, for example SHG to the UV. Some of these cases require poling periods that are so short that they are difficult to fabricate with the present state of poling technology. As mentioned above, going to higher order in the poling period (3,5,7...) is an alternative in some cases, but the efficiency drops rapidly, as $(1/\text{order})^2$. Also, the optical power levels that can be generated in the visible/UV regions can be limited by photo-refractive effects. This, however, is not a serious problem for use in optical synthesis since we don't require high powers. Future use of waveguide mixing devices could be attractive, although waveguide technology is more challenging when the wavelengths are very different.

2. CONNECTION TO CO₂ LASERS

With a dependable connection between visible wavelengths using the CO $\Delta v=2$ laser (~ 90 THz) and PPLN mixing crystals, we wanted to explore the possibility of stepping between diode laser wavelengths separated by a CO₂ laser frequency (~ 30 THz). Three CO₂ laser steps would then be able to span the CO $\Delta v=2$ laser frequency interval. Thus, we set up an experiment to sum an ECDL at 844 nm wavelength with a CO₂ laser running on the R₁(38) transition in the 10 μm band of the normal CO₂ isotopomer at a 10.134 μm wavelength.

The nonlinear crystal used for this experiment was Ag₃AsS₃ with a transparency window between 600 nm and 13 μm . Phase matching occurred at an angle of 22.6 $^{\circ}$ with both input beams in ordinary polarization. Input powers of 250 mW at 10 μm and 1 mW at 844 nm led to

an output power of 25 nW (efficiency: $\eta = 1 \times 10^{-4} \text{ W}^{-1}$) at 780 nm at extraordinary polarization. A beatnote with 25 dB signal-to-noise ratio (SNR) in a 10 kHz resolution bandwidth was sufficient to phase lock a second ECDL at 780 nm to the sum signal.

This experiment demonstrates the possibility to divide the coarser steps of the CO $\Delta v=2$ laser mixing stages phase coherently with a CO₂ laser. The CO₂ laser frequency can then be measured against Cs with a frequency chain [3,4].

3. PRELIMINARY MEASUREMENT OF THE Hg* TRANSITION

Mixing of optical frequencies in PPLN opens the possibility for an accurate measurement of the Hg* clock transition at 282 nm wavelength [5] using the Ca standard [6] as a frequency reference. The Ca frequency of the $^1S_0(m=0) \rightarrow ^3P_1(m=0)$ transition at $\nu(\text{Ca})=455\,986\,240.494$ MHz has been measured by PTB against Cs with an uncertainty of ± 135 Hz [7].

Even though the Hg* standard holds great promise for a future optical-frequency standard due to the very narrow optical clock transition $^3S_{1/2} \rightarrow ^2D_{3/2}$ ($F=0 \rightarrow F=2$, $\Delta m_F=0$) with a natural linewidth of $\Delta \nu \approx 1.7$ Hz, its absolute frequency is relatively poorly known.

Our scheme to measure the Hg* transition is based on two fortuitous 'coincidences', namely half the Hg* frequency $\nu(1/2\text{Hg}^*) = \nu(\text{Ca}) + \nu(\text{Ca})/6$, and $\nu(\text{Ca})/6 = \nu(\text{CO})$, where $\nu(\text{CO})$ is the frequency of a CO $\Delta v=2$ laser operated on the P₃₃(15) transition. Hence, we can use the CO laser as a transfer oscillator between the two optical standards. Since the 282 nm transition in Hg* can be interrogated with a frequency-doubled dye laser oscillating at 563 nm wavelength, the CO $\Delta v=2$ laser can connect between the Ca reference and the dye laser frequency.

Using a PPLN crystal with a 12.6 μm poling period we generated a difference signal between the dye laser frequency ($\nu(1/2\text{Hg}^*)$) and the CO $\Delta v=2$ laser frequency

This measurement of the Hg^+ optical clock transition frequency relative to Ca is a proof-of-principle demonstration of our measurement technique along our path toward a more precise measurement of the Hg^+ standard. In order to achieve an uncertainty of less than 1 kHz, we will also measure the $\text{CO } \Delta v=2$ laser frequency relative to the Ca frequency (Fig. 2).

A difference signal (DFG#1) between $\nu(\text{CO})$ and $\nu(\frac{1}{2}\text{Hg}^*)$ with a power of $3.5\text{ }\mu\text{W}$ is generated in PPLN and a beat signal with a 3.6 GHz offset to $\nu(\text{Ca})$ can be used for phase locking the CO laser. We have demonstrated phase locking of the CO laser by an acousto-optic modulator with a SNR of 40 dB in a 300 Hz bandwidth.

Another PPLN crystal allows doubling of the CO laser frequency $\nu(\text{CO})$, delivering 2.5 μW of power in the second harmonic (SHG#1) at 1962 nm wavelength. The SHG#1 radiation can be used to generate a beat signal with the difference frequency (DFG#2) between the ECDL and the CO laser at 1962 nm wavelength that is generated in a third PPLN for a divide-by-three scheme of the ECDL. We achieve a 150 nW DFG#2 signal with input powers of 4 mW and 80 mW for the ECDL and the CO laser, respectively, leading to a beat note of 55 dB SNR in a 30 kHz bandwidth between the SHG#1 and DFG#2. We have shown that this beat signal can be used for phase locking the ECDL to the third-harmonic of the CO laser (Fig. 3).

For this purpose the CO laser is stabilized by phase locking it (with a frequency offset) to the frequency difference, $\nu(\frac{1}{2}\text{Hg}^+) - \nu(\text{Ca})$. The use of different nonlinear mixing stages in PPLN permits an effective multiplication of 6 times the CO laser frequency for comparison with $\nu(\text{Ca})$. An ECDL with a frequency $\nu(\text{DL})$ at $1.3 \mu\text{m}$

A last PPLN crystal is used for doubling the ECDL (SHG#2) to $2\nu(\text{DL})$, close to the Ca reference frequency $\nu(\text{Ca})$. A power of 200 nW in the SHG#2 was achieved using 5 mW input power of the ECDL.

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eously and to measure the 2.24 THz frequency gap between the SHG#2 at 654 nm and the Ca reference at 657 nm. This interval will be bridged by an optical frequency comb generator [9-10] that is currently being built in our group.

4. ROUTE FROM THE VISIBLE TO THE CESIUM CLOCK

Our next major step is to measure the frequencies of Hg^+ , Ca, and other important optical references relative to the primary Cs atomic frequency standard. The scheme we are developing for this purpose is diagramed below.

Three separate, but interconnected, frequency bisections are indicated in Fig. 4, and these require making the difference-frequency between each end point and the mid point equal. Alternatively, these could be implemented by the SHG plus SFG bisection method described by Telle et al. [11]. Whichever approach is most appropriate can be chosen for the particular wavelengths involved. Until recently, we had planned to continue the frequency chain shown in Fig. 4 by using CO_2 lasers as described in section 2. However, our present plan is to take advantage of the revolutionary new results from Udem and Hänsch et al. who have shown that it is possible to measure frequency intervals as large as 20 THz using femtosecond mode-locked lasers [12]. Using their method we plan to

measure the interval between the 788 and 750 nm (~ 19 THz) lines shown in Fig. 4 with a pulsed Ti:sapphire laser. Much work remains to be done, however, with these new improved tools, such as diode lasers, PPLN and mode-locked lasers, and with some of the suggested schemes discussed, we believe that the path to precise optical frequency measurements is clear. We also feel that these new measurement systems are coming together just as the optical references are also reaching interesting performance levels. The hope is these optical standards will be able to compete favorably with microwave standards in terms of stability and accuracy.

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Figure 4. Diagram of proposed optical frequency measurement system to connect the Hg^+ and Ca references to the Cs clock. This relies on the sub-units described above, and we have added two new lasers: one at 788 nm that bisects the frequency interval between 563 nm and 1315 nm, and one at 750 nm that bisects the frequency interval between 563 nm and 1126 nm ($\frac{1}{2}$ the 563 nm laser frequency). The boxes labeled "DFG PPLN" imply difference-frequency generation in periodically-poled lithium niobate etc.

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